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BY:

Renée Conte

Date:

January 10, 2005

MAIL STOP AMENDMENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of:
Il-Joo Cho et al.

Conf. No.: 5358

: Group Art Unit: 2881

Appln. No.: 10/777,941

: Examiner: David A. Vanore

Filing Date: February 12, 2004

: Attorney Docket No.: 10061-17U1
(P02000-11US/D)

Title: Method of Fabricating Probe for Scanning Probe Microscope

AMENDMENT

This is in response to the Office Action dated October 8, 2004 (Paper No. 100504). This response is being timely submitted by January 10, 2005 (January 8, 2005 being a Saturday).

Please amend the above-identified application, without prejudice, as follows: